



2827

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cyril Cabral Jr.

Group Art Unit: 2827

Serial No.: 09/686,742

Examiner: Lourdes Cruz

Filed: Oct. 11, 2000

For: Semiconductor Structure Having In-Situ Formed  
Unit Resistors and Method for Fabrication

Attorney Docket No.: 64,610-057 (YOR9-2000-0361US1)

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

Date: Nov. 29, 2002

Kathy Dixon

SUPPLEMENTAL AMENDMENT

Assistant Commissioner  
for Patents  
Washington, D.C. 20231

Dear Sir:

Please enter the following amendments and consider the following remarks.

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DEC -5 2002

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